



07P-1734

In re application of: Trung T. Doan

Serial No.: 09/133,989

Filed: August 14, 1998

For: CHEMICAL DISPENSING SYSTEM  
FOR SEMICONDUCTOR WAFER  
PROCESSING

§ Group Art Unit: 1734  
§ Examiner: L. Edwards  
§ Atty. Docket: 93-0421.03  
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Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below:

8-28-01

Date

*Irish Roman-Hunter*  
Signature

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136(a)

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Applicant hereby petitions to extend the period for response to the Office Action mailed February 28, 2001 for three (3) month, from 5/28/01 to 8/28/01.

Accordingly, the requisite fee is \$ 890. The Commissioner is requested to charge this fee, and any additional fee which may be required to Micron Technology, Inc. Deposit Account 13-3092, Order No. 93-0421.03. A duplicate copy of this petition is enclosed.

Respectfully submitted,

*Charles Brantley*

Date: 8/28/01

Charles Brantley  
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